# **Special Issue**

# Advanced Developments in Droplet Microfluidics

## Message from the Guest Editor

The field of droplet microfluidics has rapidly developed over the past decade, leading to many innovative applications, and continues to evolve, showcasing the latest achievements in material science, artificial intelligence, and 3D printing. For instance, droplet generation is currently being investigated to increase throughput and make this technology more accessible, and efforts to improve robustness, throughput, and ease of use are gaining momentum. Beyond droplet manipulations, this technology has played a key role in enabling novel biological or chemical applications, including high-throughput cell or bacteria screening and single-cell genomics. This Special Issue seeks to showcase all the aspects of the exciting field of droplet microfluidics, including, but not limited to, technology development, applications, and open-source systems.

### **Guest Editor**

Dr. Fric Brouzes

Department of Biomedical Engineering, Stony Brook University, Stony Brook, NY 11794, USA

### Deadline for manuscript submissions

31 January 2026



## **Micromachines**

an Open Access Journal by MDPI

Impact Factor 3.0 CiteScore 6.0 Indexed in PubMed



mdpi.com/si/246155

Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

mdpi.com/journal/micromachines





an Open Access Journal by MDPI

Impact Factor 3.0
CiteScore 6.0
Indexed in PubMed



## **About the Journal**

## Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

#### Editor-in-Chief

Prof. Dr. Ai-Qun Liu

Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China

#### **Author Benefits**

### **High Visibility:**

indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, dblp, and other databases.

## **Journal Rank:**

JCR - Q2 (Instruments and Instrumentation) / CiteScore - Q1 (Mechanical Engineering)

### **Rapid Publication:**

manuscripts are peer-reviewed and a first decision is provided to authors approximately 17.2 days after submission; acceptance to publication is undertaken in 1.9 days (median values for papers published in this journal in the first half of 2025).

